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Bib Data Sheet

CONFIRMATION NO. 3457

SERIAL NUMBER 10/699,460	FILING DATE 11/03/2003  RULE	CLASS 438	GROUP ART UNIT 2829	ATTORNEY DOCKET NO. 70404.10
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\*\* CONTINUING DATA \*\*\*\*\* IA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* IA \*\*\*\*\*  
 JAPAN 2002-325677 11/08/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 02/02/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	STATE OR COUNTRY JAPAN	SHEETS DRAWING 20	TOTAL CLAIMS 68	INDEPENDENT CLAIMS 3
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TITLE  
 Semiconductor film, method for manufacturing semiconductor film, semiconductor device, and method for manufacturing semiconductor device

FILING FEE  RECEIVED 1764	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____
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